

Application No.	Applicant(s)	
10/092,094	SU ET AL.	
Examiner	Art Unit	
Jean M Corrielus	2172	

SEARCHED				
Class	Subclass	Date	Examiner	
715	501	6/10/2004	JMC	
715	512	6/10/2004	JMC	
715	513	6/10/2004	JMC	
715	522	6/10/2004	JMC	
715	523	6/10/2004	JMC	
715	530	6/10/2004	JMC	
707	104	6/10/2004	JMC	
707	103	6/10/2004	JMC	
707	102	6/10/2004	JMC	
707	101	6/10/2004	JMC	
707	10	6/10/2004	JMC	
707	6	6/10/2004	JMC	
707	3	6/10/2004	JMC	
707	2	6/10/2004	JMC	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
707/	102	6/14/2004	JMC	
707	6	6/14/2004	JMC	
715	513	6/14/2004	JMC	
707		6/14/2004	JMC	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
WEST	6/10/2004	JMC	
NPL (ACM, IEEE)	6/10/2004	JMC	
DIALOG	6/10/2004	JMC	
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